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<ol> <li>PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES)</li> <li>University of Michigan</li> <li>1301 Beal Ave, EECS Department, Ann Arbor, MI 48109-2122</li> </ol>			8. PERFORMING ( REPORT NUMB	ORGANIZATION ER RadLab 03729Dec01
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We have developed the first Micapacitor which is composed of a voltage at 1.64 MHz. This induces signal at 200 kHz. To our knowled with an up-conversion ratio of 9:1 of the MEMS time-varying capacit high particle bombardment (nucleamplifiers do not suffer from them	s a large change in the capacitand dge, this device is the first-ever Mi . The measurements agree very v or. The application areas are in ar ar applications), in non semicond	licon-nitride diaphre, and results in passession of mechanical underly incoming the model of the mechanical with theory, incomplifiers which opeductor-based amplif	agms, and is pumparametric amplification perconverter parametrication the effect the rate at very high to	ped by a large signal ation of an input the series resistance and the Querperatures (200-600C), under noise systems since parametric
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Sincerely,

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# REPORT DOCUMENTATION PAGE (SF298) (Continuation Sheet)

#### **Accomplishments:**

We have developed the first MEMS parametric amplifier for Sonar applications. The device used is a MEMS time-varying capacitor which is composed of an array of low-stress metalized silicon-nitride diaphragms, and is pumped by a large signal voltage at 1.64 MHz. This induces a large change in the capacitance, and results in parametric amplification of an input signal at 200 kHz. To our knowledge, this device is the first-ever MEMS mechanical up-converter parametric-effect amplifier developed with an up-conversion ratio of 9:1. The measurements agree very well with theory, including the effect the series resistance and the Q of the MEMS time-varying capacitor. The application areas are in amplifiers which operate at very high temperatures (200-600C), under high particle bombardment (nuclear applications), in non semiconductor-based amplification, and in low-noise systems since parametric amplifiers do not suffer from thermal, shot or {\mathbb{e} 1/f} noise problems.

#### **Publications:**

- J.P. Raskin, A.R. Brown, B.T. Yakub and G.M. Rebeiz, "A novel parametric-effect MEMS amplifier," *IEEE Trans. Micro. Electro. Mechanical Systems*, Vol. 9, pp. 528-537, Dec. 2000.
- J.P. Raskin, A.R. Brown, B.T. Khuri-Yakub and G.M. Rebeiz, "Novel parametric-effect MEMS amplifiers/transducers," *Transducers* 2000, Hilton Head, June 2000.

#### **Post-Doctoral Personel Supported:**

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